

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

---

Patent Application of:

Sung-Hwa LEE et al.

Application No.: 10/539,552

Confirmation No.: 2680

Filed: June 16, 2005

Art Unit: 3742

For: COOLING STRUCTURE FOR PLASMA  
LIGHTING SYSTEM

---

Examiner: Q. T. Van

**AMENDMENT UNDER § 1.111**

**MS AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In reply to the Office Action dated November 20, 2010, the period for reply having been extended to March 22, 2010 (March 20, 2010 being a Saturday) with a petition for extension of time filed herewith, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 6.